



**ELECTRONIC COPY**

LG779650419  
Report verification at igi.org

**LABORATORY GROWN DIAMOND REPORT**

March 10, 2026  
IGI Report Number **LG779650419**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **8.80 X 6.49 X 4.06 MM**

**GRADING RESULTS**

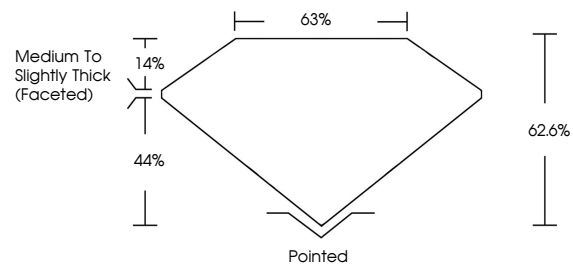
Carat Weight **1.49 CARAT**  
Color Grade **F**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG779650419**

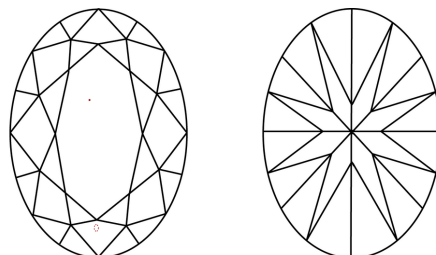
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

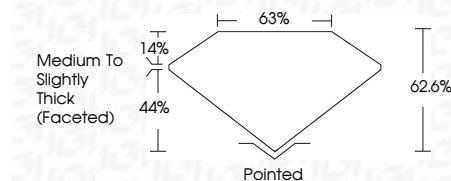
D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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OVAL BRILLIANT  
8.80 X 6.49 X 4.06 MM  
Carat Weight 1.49 CARAT  
Color Grade F  
Clarity Grade VVS 2  
Depth 62.6%  
Table 63%  
Girdle Medium to Slightly Thick (Faceted)  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG779650419  
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